



10-31-05

1/11/05

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	PATENT APPLICATION
Inventors: Yoshi Ono)	
Serial No.: 10/602,194)	Attorney Docket No. SLA0669
Filed: June 23, 2003)	Group No. 2823
Title: LOW TEMPERATURE NITRIDATION OF SILICON)	Examiner: Khiem D. Nguyen
)	Confirmation No. 9996

Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

ASSOCIATE POWER OF ATTORNEY
CHANGE OF CORRESPONDENCE ADDRESS

I hereby appoint Robert D. Varitz of 4915 S.E. 33rd Place, Portland, Oregon 97202, U. S. Patent and Trademark Office Registration Number 31436, as an associate attorney for the above-captioned matter, with full power of substitution and revocation, to prosecute this application and to transact all business in the Patent and Trademark Office connected therewith.

Please change the Correspondence Address to that associated with Customer Number 55,376.

Date:

10/25/05

Respectfully submitted,

David C. Ripma
Registration No. 27,672

David C. Ripma, Patent Counsel
Sharp Laboratories of America, Inc.
5750 NW Pacific Rim Boulevard
Camas, WA 98607

Telephone: (360) 834-8754
Facsimile: (360) 817-8505